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APPLICANTS

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 ** CONTINUING DATA ***** *NONE CME*

 ** FOREIGN APPLICATIONS ***** *CME*
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35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>C. Hueston</i> Examiner's Signature	<i>CME</i> Initials			

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TITLE

Method for operating chemical mechanical polishing ("CMP") tool for the manufacture of semiconductor devices

FILING FEE RECEIVED 874	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other
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